Search Notes			

Application/Control No	. Applicant(s)/Patent under Reexamination	
09/699,863	HEISKA, JUKKA	
Examiner	Art Unit	
Tammy T. Nguyen	2144	

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
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